

05/24/01

05-29-01

A

Docket No. 005332/DISPLAY/AKT/BG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Re: Inventor(s): **Sheng Sun**
Title: **Photo-Assisted Chemical Cleaning and Laser Ablation Cleaning of Process Chamber**

11000 U.S. PTO
09/866171
05/24/01

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 42 pages.
- ☒ Drawings totaling 2 pages, Formal ☒ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☒ Assignment of the invention to Applied Materials, Inc.
- ☒ Assignment Recordation Cover Sheet
- Information Disclosure Statement, PTO Form 1449 and () References

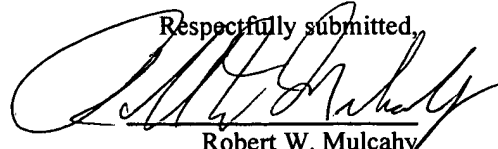
FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	- 68	- 20 =	-48	X \$18	\$864
Independent Claims	-11	- 3 =	- 8	X \$80	\$640
Basic Filing Fee				\$710	\$710
TOTAL FEES					\$2,214

- ☒ The Commissioner is hereby authorized to charge \$2,214 to Deposit Account No. 50-1074
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

Express Mail Receipt No. EL661804714US
Date of Deposit 5-24-01
Signature Bob Mulcahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436